

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Robert H. Havemann

Serial No.: 09/216,214

Filing Date: 12/18/98

Title: Enhancements to Polysilicon Gate



Docket No.: TI-21570

Examiner: Not Determined

Art Unit: 2812

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6-10-99

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Information Disclosure Statement

Assistant Commissioner for Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being deposited with
the U.S. Postal Service as First Class Mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, D.C. 20231.

Dear Sir:


Tina Rendon

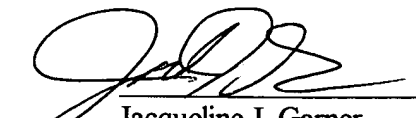
3-18-99
Date

Applicant wishes to bring the references noted on the enclosed PTO-1449 to the attention of the Patent and Trademark Office. The enclosed articles and/or patents listed on the attached PTO 1449 form are deemed relevant to the examination of the subject application.

Please charge any additional fees to deposit account 20-0668.

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Respectfully submitted,


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